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PTO/SB/08A (08-00)

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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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## **Complete if Known**

Application Number	09/535,015
Filing Date	March 24, 2000
First Named Inventor	Shunpei YAMAZAKI et al.
Group Art Unit	2811
Examiner Name	S. Crane
Attorney Docket Number	0756-2131

Sheet 1 of 1

## **U.S. PATENT DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>4</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				

## **OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
SC		NEMANICH, R.J. et al., <i>Structure and Growth of the Interface of Pd on a-SiH</i> , The America Physical Society - Physical Review, Vol. 23, No. 12, Pages 6828-6831, June 1981.	

Examiner Signature	/Sara Crane/	Date Considered	05/12/2006
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

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		<del>NEMANICH, R. J. et al., Structure and Growth of the Interface of Pd on a Si(111), The America Physical Society - Physical Review, Vol. 23, No. 12, Pages 6026-6231, June 1981. see I.D.S. of May 02 2006</del>	

Examiner Signature	/Sara Crane/	Date Considered	05/12/2006
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Patent and Trademark Office

Attorney Docket No. 0756-2131

Serial No. Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT**

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI et al.

Filing Date: March 24, 2000

Group: 2811

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09/539015

03/24/00

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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	5,426,064	06/20/95	Zhang et al			
	5,481,121	01/02/96	Zhang et al			
	5,488,000	01/30/96	Zhang et al			
	5,492,843	02/20/96	Adachi et al			
	5,501,989	03/26/96	Takayama et al			
	5,508,533	04/16/96	Takemura			
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	5,563,426	10/08/96	Zhang et al			
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5/11/2000 <del>SWL</del>	R.J. Nemanich et al, "Structure and Growth of the Interface of Pd on $\alpha$ -SiH", The American Physical Society - Physical Review, Vol. 22, No. 12, pp. 6828-6834, June 1984
SWL	M.J. Thompson et al, "Silicide Formation in Pd- $\alpha$ -Si:H Schottky Barriers", Appl. Phys. Lett., Vol. 39, No. 3, pp. 274-276, August 1981
SWL	Hayashi et al., "Fabrication of Low-Temperature Bottom-Gate Poly-Si TFTs on Large-Area Substrate by Linear-Beam Excimer Laser Crystallization and Ion Doping Method", IEEE IEDM 1995, pages 829-832.
SWL	R.J. Nemanich et al, "Initial Phase Formation at the Interface of Ni, Pd, or Pt and Si", Mat. Res. Soc. Symp. Proc., Vol. 25, 1984

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